

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Kohei KAWAMURA, et al.

SERIAL NO: 10/567,733

GAU: 2823

FILED: February 10, 2006

EXAMINER: Kevin A. PARENDO

FOR: METHOD FOR FORMING FILM, METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE, SEMICONDUCTOR DEVICE AND
SUBSTRATE TREATMENT SYSTEM

**REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136**

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

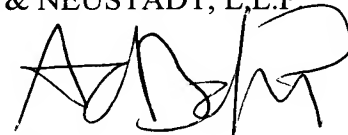
It is hereby requested that a **three** month extension of time be granted to October 8, 2009 for

- ☒ filing a response to the Official Action dated: April 8, 2009
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☐ filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐ Applicant claims small entity status. See 37 CFR 1.27.

The required fee of \$1,110.00 is being made by credit card payment online (if electronically filed), or is attached hereto (if paper filed), and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, L.L.P.



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